

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Toshiro YAMADA, et al.

Serial Number: Not Yet Assigned

(§371 of International Application PCT/JP03/09023)

Filed: January 14, 2005

For. METHOD OF DRY ETCHING, DRY ETCHING GAS AND PROCESS

FOR PRODUCING PERFLUORO-2-PENTYNE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

January 14, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

INFORMATION DISCLOSURE STATEMENT PTO-1449

Atty. Docket No. 050011

Serial No. New Application 272

Applicant(s): Toshiro YAMADA, et al.

Filing Date: January 14, 2005

Group Art Unit: Not Yet Assigned

U.S. PATENT DOCUMENTS

Examiner "Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
•	AA						
	AB						
	AC						
	AD						

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
 AE	2000-206704	07/28/00	Japan	Cited in the International Search Report
 AF	2001-110790	04/20/01	Japan	Cited in the International Search Report
 AG	WO 00/30168 A	02/25/00	PCT	Cited in the International Search Report
 AH	2003-282540	10/03/03	Japan	Cited in the International Search Report
 AI	755909 A	01/29/97	EP	Cited in the International Search Report

OTHER DOCUMENTS

	AJ	
	AK	
Examiner		Date Considered